

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
AND SUBMISSION OF CORRECTED FORM PTO-1449

Supplemental to an information disclosure statement filed with the application on March 4, 2010, applicants submit the attached corrected Form PTO-1449. All of the documents listed on the form PTO-1449 were cited in information disclosure statement filed with the application. The corrected Form PTO-1449 is being submitted to correct an error in the description of the reference identified as Desig. ID "15." Please note that, for this reference, the Document Translation has been changed from "Full" to "ABS." The correction is identified by **'s and bold print.

No fee is believed due at this time. Please apply any charges or credits not associated with the filing fee to deposit account 06-1050.

Respectfully submitted,

Date: 9/5/19

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